

## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Li et al.	I hereby certify that this paper is being deposited with the United States Postal Service as FIRST-CLASS mail in an envelope addressed to: Mail Stop Non Fee Amendment Commissioner for Patents, P.O. Box 1450, Alexandria, Ve. 22313-1450, on this date.    Date Registration No. 35731   F-CLASS.WCM   Appr. February 20, 1998   Attorney for Applicant
Serial No.:	09/662,682	
Conf. No.:	1914	
Filed:	September 15, 2000	
For:	METAL-ASSISTED CHEMICAL ETCH POROUS SILICON FORMATIOM METHOD	
Art Unit:	1765	
Examiner:	Vinh, Lan	) RECEIVED
		OCT 2.9 2003
Commissioner for Patents		TO :=
P.O. Box 1450		TC 1700
Alexandria V	Δ 22313-1450	• • • • • • • • • • • • • • • • • • • •

## **AMENDMENT TRANSMITTAL**

Dear Sir:

Transmitted herewith is a communication regarding the above-identified application.

- (X) Response A.
- (X) If a Petition under 37 C.F.R. 1.136(a) for an extension of time for response is required to make the attached response timely and does not separately accompany this transmittal, Applicant(s) hereby petition(s) under 37 C.F.R. 1.136(a) for an extension of time for response in the above-identified application for the period required to make the attached response timely.
- (X) The Commissioner is hereby authorized to charge any additional fees which may be required to this application under 37 C.F.R. 1.16-1.17, or credit any overpayment, to Deposit Account No. 07-2069. A duplicate copy of this sheet is enclosed.

October 7, 2003

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Respectfully submitted,

GREER, BURNS & CRAIN, LTD.

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